

Representative
Patent Attorneys
YOUNGPIL LEE
Y.T. MOCK

Remarks &
Litigation
HOWARD JEAN * 1) 2)
HENGSHUB JIN * 1)
JOONHYO KIM * 1)
DAESIK KIM *
TAEHO LEE *
JORDAN YONGSIK KIM *
SUNYOUNG MOCK *
SEUNGYONG LEE *
EUNKYUNG AHN *
HEEWON SEO *
YOONKYUNG CHO *
JAEHEUNG YOO
JESSICA SUH

Biotechnology &
Pharmaceuticals
SUKHEUM KWON *
KOOKJIN OH *

* Korean Patent Bar
1) Korean Bar
2) U.S. State Bar

SANGBIN JEONG *
MOONSUB LEE *
SUKMYUNG LEE *
MINJEONG LEE *
BYUNGJAE KIM *
EUNHUI JOO *
YONGWOON KIM *

Chemistry &
Material
EUIBAK KIM *
JONGCHEOL HYUN *
YUJO PARK *
GILJE WOO *
HYUNJU KIM *
HYESOOK PARK *
HANA JOOHYUN KIM *
GILJA KWON
JUNGSUN KIM
BOHEE CHAI
BUMTAK HAN

Mechanics
JEONGKEUN LEE *
HEUNYOUNG YANG *
UNSUH KOO *

Y.P. LEE, MOCK & PARTNERS

(Y.P. Lee & Associates + D.S. Mock Patent Office)

CHEONGHWA BUILDING
1571-18 SEOCHO-DONG, SEOCHO-GU
SEOUL, REPUBLIC OF KOREA 137-874

TEL: (82) (2) 588-8585
FAX: (82) (2) 588-8586
588-8547/8

E-mail: iplaw@leemock.com
iplaw@ypleepat.com
Website: <http://www.leemock.com>
<http://www.ypleepat.com>

24 October 2003

Mechanics (Cont.)
HYUNTAE CHA *
JIYOUNG SEO *
JOONHEE JOO *
DONGWOO HONG *
SOOYOUNG HA *
YONGJOON KIM *
YOUNGKYU KWON *
KYUSEUNG CHOI *
YONGJOON JEON *
JAEGBA LEE *
HUNCHUL PARK
HYOUNGSUK KO
JIEON RYU
CHANGGIL JOO
SANGTAE PARK
GONGSOOK SOHN
SEONGYONG LEE
CORNEL IURASCU

Electronics
HAEYOUNG LEE *
HOKEUN LEE *
YURI KIM *
KYEONGKEUN SONG *
JAEHO SHIN *

SANGPIL LEE *
JUNGSIK KIM *
BYUNGKEE SUNG *
JANGHYUK LEE *
JAESEOK YOON *
BOKYUNG PARK *
JAESEUNG YOON *
KYUNGYUL YU *
YOUNGCHUL KIM *
JINSUK PARK *
YOUNGJAE KIM *
CHANHONG JANG
SANGHEE KIM
KUYHYUN KIM
WANHO KIM
JOONGKEUN MOON
TAEONG KIM
SEOKJIN HWANG
DONGSUNG PARK
OHJOON KWON
DAEWOONG KIM
HYUNJUNG KIM
WANGPIL KIM
BUMSIK PARK
INSUK LEE
JAEHOON SHIN
SEAN BAXENDELL
DAVID R. COOK

Darryl Mexic, Esq.
Sughrue, Mion, PLLC
2100 Pennsylvania Avenue, N.W.
Washington, D.C 20037-3213
U.S.A.

VIA COURIER

Your Ref.: Q62787

Our Ref.: SH-15006-0

RECEIVED

Re: U.S. Patent Application No. 09/801,060
Samsung Electronics Co., Ltd.

OCT 31 2003

Technology Center 2600

Dear Mr. Mexic:

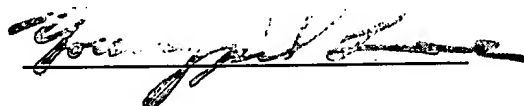
In connection with the above-identified application, please be informed that five references were cited in the Search Report dated 27 June 2003 of the European Patent Application No. 01301730.6 which corresponds to the above U.S. application. Thus, we enclose herewith copies of the search report together with copies of the cited references.

To meet the duty of disclosure, please take the necessary steps for submitting an Information Disclosure Statement in due course.

We appreciate your cooperation in this case.

Sincerely yours,

Y.P. LEE, MOCK & PARTNERS


Youngpil Lee

YPL/jja
Enclosure